

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**INFORMATION DISCLOSURE  
STATEMENT**

Docket Number:  
12013/50501

Application Number <b>To Be Assigned</b>	Filing Date <b>Herewith</b>	Examiner <b>To Be Assigned</b>	Art Unit <b>To Be Assigned</b>
Invention Title <b>A MATRIX ASSISTED PULSED-LASER EVAPORATION TECHNIQUE FOR COATING A MEDICAL DEVICE AND ASSOCIATED SYSTEM AND MEDICAL DEVICE</b>		Inventor(s) <b>Anthony Malone</b>	

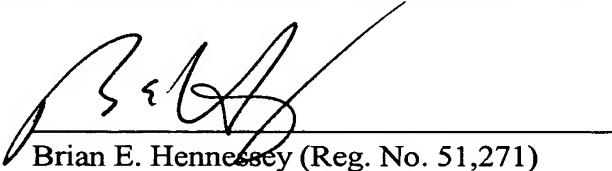
Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 35 U.S.C. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicant hereby bring the following reference to the attention of the Examiner. This reference is listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
2. A copy of each patent, publication or other information listed on the modified PTO Form 1449 is enclosed.

Dated:

*2/27/04*

By:



Brian E. Hennessey (Reg. No. 51,271)

KENYON & KENYON  
One Broadway  
New York, New York 10004  
(212) 425-7200 (telephone)  
(212) 425-5288 (facsimile)

Customer No. 26646

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	ATTY. DOCKET NO. 12013/50501	SERIAL NO. To Be Assigned
	APPLICANT Anthony Malone	
	FILING DATE Herewith	GROUP To Be Assigned

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/ PUBLICATION NUMBER	PATENT/ PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE*
	5,091,205	February 25, 1992	Fan			
	6,419,996	July 16, 2002	Mueller et al.			
	2001/0011545	August 9, 2001	Thompson et al.			

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

**OTHER DOCUMENTS**

Examiner Initials *	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	P.K. Wu, et al., "The Deposition, Structure, Pattern Deposition, and Activity of Biomaterial Thin-films by Matrix-assisted Pulsed-laser Evaporation (MAPLE) and MAPLE Direct Write," Thin Solid Films, Vols. 398-399, November 2001, pages 607-614.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

671327